



JPW

PATENT  
ATTORNEY DOCKET NO.: 052640-5031-01

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	Confirmation No. 5216
Namwoong PAIK et al.	)	
	)	Group Art Unit: 1753
Application No.: 10/695,485	)	
	)	Examiner: Unassigned
Filed: October 29, 2003	)	
	)	
For: METHOD OF FORMING NON-OXIDE	)	
THIN FILMS USING NEGATIVE	)	
SPUTTER ION BEAM SOURCE	)	

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO-1449. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application. Accordingly, Applicants do not believe that a fee is due for filing this paper. The listed documents were previously cited in the co-pending parent Application No. 10/300,783, filed on November 21, 2002, upon which Applicants rely on the benefits provided in 35 U.S.C. § 120. Thus, under 37 C.F.R. § 1.98(d), copies of the listed documents are not being submitted herewith.

Applicants respectfully request that the Examiner consider the listed documents and evidence that consideration by making appropriate notations on the attached PTO 1449 form.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "Prior Art." If it should be determined that any of the listed documents do not constitute "Prior Art" under United States law, Applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

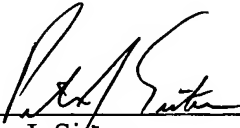
Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Information Disclosure Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

**MORGAN, LEWIS & BOCKIUS LLP**

Dated: November 10, 2004

By:   
Peter J. Sistare  
Reg. No. 48,183

**Customer No.: 009629**  
**MORGAN, LEWIS & BOCKIUS LLP**  
1111 Pennsylvania Avenue, N.W.  
Washington, D.C. 20004  
Tel: 202.739.3000  
Fax: 202.739.3001

